

Notice of References Cited	Application/Control No. 10/815,858	Applicant(s)/Patent Under Reexamination BRYAN, ERIC F.	
	Examiner Yaritza Guadalupe McCall	Art Unit 2859	Page 1 of 2

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6,792,792	09-2004	Babala, Michael L.	73/1.38
	C	US-6,171,880	01-2001	Gaitan et al.	438/52
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	F	US-3,892,042	07-1975	Senften, David A.	33/301
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	H	US-6,741,169	05-2004	Magiawala et al.	73/146.2
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*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	"Convection-based Accelerometer and Tilt Sensor Implemented in Standard CMOS" Milanovi et al., Intl. Mechanical Eng. Conf. and Expo., MEMS Symposia, Anaheim, CA , Nov. 18, 1998, (4 Pages).
	V	"A Micromachined Thermal Accelerometer for Motion, Inclination, and Vibration Measurement", Bugnacki et al., Sensors - June 2001, (11 Pages).
	W	"Innovation in MEMS: Full Integration of Micro-machined Motion sensors with no Moving Pads", Bugnacki et al., Dedicated Systems Magazine, 2001 Q4 pages 6-12 (7 Pages).
	X	"A Dual-Mis Tilt Sensor Based on Micromachined Accelerometers", Hodon et al., Sensors - April 1996, pages 91-94 (4 Pages).

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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	U	Analog Devices Press Release MMulti-purpose Accelerometer Measures Low g Forces with 0.005g Resolution IADXLOSID, Norwood, MA, May 1, 1995, 2 pages.
	V	Crossbow Technology, Inc.: San Jose, CA - Domestic Price List and Product Literature for "CXTILT02Dual Axis Dlgital Tilt Sensor" and UCXLO4M3 Triaxial Accelerometer" dated May 6, 1996 (8 pages).
	W	Affidavit of Mr. John Crawford of Crossbow Technology, Inc. attesting to associated correspondence between Mr. Nick Colarelli of Hunter Engineering Co. and Mr. John Crawford dated August 1996 regarding the use of Crossbow Technology, Inc.'s MEMS dual-axis
	X	

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